



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

is application of

Yoichiro NUMASAWA et al.

Serial No. 10/642,619

Filed August 19, 2003

APPARATUS AND METHOD FOR
MANUFACTURING HALOGEN GAS
AND HALOGEN GAS RECOVERY
AND CIRCULATORY SYSTEM

: **Confirmation No. 3771**

: Attorney Docket No. 2003_1106A

: Group Art Unit 1754

: Examiner Ngoc Yen M. Nguyen

: **Mail Stop: Amendment**

RESPONSE TO RESTRICTION/SPECIES ELECTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction/Species Election Requirement dated September 13, 2005, the period for response having been extended for five months extension by the attached petition, Applicants hereby elect Group I, claims 1-7, drawn to a process for manufacturing halogen gas.

Applicants further elect A_iX_j as the species of gas used as the starting material for I and Si as the species for "A". It is respectfully submitted that at least claims 1, 2 and 5-7 are readable on the elected species.

Favorable action on the merits is solicited.

Respectfully submitted,

Yoichiro NUMASAWA et al.

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

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